## Polygon mirror scanner PM series

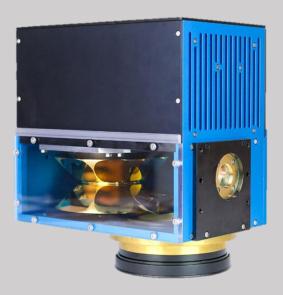


Ultrafast 2D beam deflection

High aperture

High power applications





MOEWE's polygon mirror scanners (PM) are designed for ultra-fast high-power laser processing. The system is realized as two-dimensional beam deflection unit available for 2D and 2.5D processing.

#### **KEY FEATURES**

- Patented low distortion double polygon mirror
- Large free aperture of 30 mm
- High laser power of 5 kW cw / 3 kW pulsed
- Ultra-fast scan speeds on the entire scanning field (no acceleration loss)
- Full digital, FPGA on-board data processing
- Bitmap graphics up to 32-bit resolution
- Real-time laser switching for highest accuracy

### **Options and variants**

### **Optics**

- Changeable f-theta lenses (standard or customized)
- Optics datasheet for suitable f-thetas available

### Hardware

- Encoder IO for treating moving substates
- Fast laser trigger outputs TTL and anlogue

The high-end PM scanners stands out with a with a free aperture of 30 mm and a real-time on-board data processing allowing highest accuracy for macro and micro processing on never seen throughputs.

### YOUR ADVANTAGES

- Two-dimensional beam deflection allows standalone utilization or machine integration (axis, rollto-roll)
- Multiple digital and analog I/O connectors, Ethernet for communication, encoding, process control
- Applications: Laser marking, micro structuring, Surface cleaning, Drilling, Cutting, spot welding, Engraving (2.5D), and more

### Software

- Parameter, bitmap graphics mode
- Up to 32-bit greyscale processing, engraving 2.5D
- Synchronization of multiple scanners
- Real time shifter for dynamic processing

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### **General specifications**

	Voltage	+(30±2) V <sub>DC</sub> , GND
Power supply	Current	max. 15 A
	Ripple/Noise	max.200 mVpp
Operating temperature		+18+30°C
Humidity		2090 % rel.H.
Wight		13 kg
Size (LxWxH)		281 x 226 x 253
Input aperture		29.5 mm
Beam displacement		0 mm

### Input / Output

Data transfer	1x	Ethernet
Digital Out	3x	5 V @ 120 MHz
Analog Out	2x	05 V @ 3 MHz
Analog In	1x	05 V
Axis I/O	36 pin	D-Sub-Micro-D
Sync I/O	Master/slave	RJ45
GPIO I/O	20 pin	D-Sub-Micro-D
Aux. I/O	9 and 15 pin	D-Sub
USB 2.0 A		5 V, max. 0.5 A

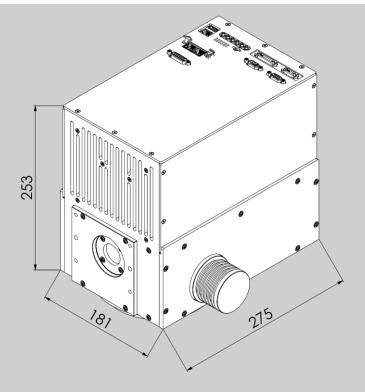
### **Optical specifications**

	Polygon mirror	Galvo mirror
	Primary axis	Secondary axis
Max. deflection	± 0.454 rad	± 0.698 rad
Resolution	<2 μrad (24-bit)	< 4 µrad (20 bit)
Repeatability	20 μrad	20 μrad (RMS)
Temp. Drift		< 5 μrad/K
Max. Lines / s	1,333 Hz @ 10,000 rpm	
Max. scan speed	> 800 m/s @ 10,000 rpm, 420 mm f-θ	
Wavelenght	NIR1,030-1,080 nm	
	VIS 515 / 532 nm	
	UV 343 / 355 nm	
	other on request	

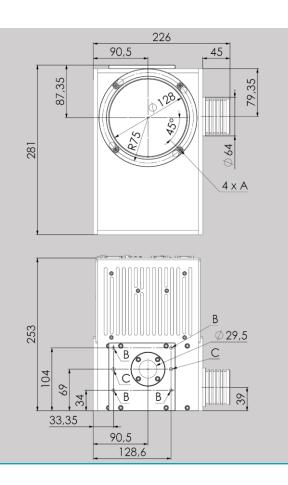
### Real-time FPGA processing

On-board memory	2 GByte
Scanning field	90 000 x 90 000 pixel
FPGA frequency	200 MHz, (5 ns)
2D b/w bitmaps	BMP (1-bit)
2.5D grey bitmaps	BMP (8,16,24 or 32 bit)

### Drawings



- A: M5 for objective adapter ring, max. screw-in 10 mm
- B: M6 for scanner mounting, max. screw-in 10 mm
- C: Ø 6 H7 x 20 for dowel pins ISO 2338-6 m6



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